

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/679,711	CHEN ET AL.	
Examiner	Art Unit	
Javaah A Datal	0005	

SEARCHED					
Class	Subclass	Date	Examiner		
382	128,163,1 66	11/9/2006	JP		
382	261,262,	11/9/2006	JP		
600	101	11/9/2006	JP		
348	45	11/9/2006	JP		

INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		
					
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SEARCH NO (INCLUDING SEARCH	TES STRATEGY)
•	DATE	EXMR
SEE ATTACHED EAST HISTORY	11/9/2006	JP
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